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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 3491**
Yoshihiro YANAGI et al. : Docket No. 2004_0411A
Serial No. 10/801,551 : Group Art Unit 2812
Filed March 17, 2004 : Examiner Alexander G. Ghyka
PLASMA PROCESSING METHOD AND :
APPARATUS :

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

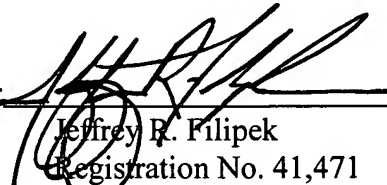
Pursuant to the requirement set forth in the Office Action of September 23, 2005, Applicants hereby elect Invention I. Claims 1-3, and 6 read on the elected invention. Please note that the Examiner indicated that claim 6 was included in Invention II. However, claim 6 is drawn to the plasma processing method, which is grouped in Invention I, whereas Invention II is drawn to a plasma processing apparatus.

In view of this election, a full examination on the merits of the present application is respectfully requested.

Respectfully submitted,

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